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WORKPIECE HOLDING MECHANISM FOR A PLANE POLISHING DEVICE

Inventors:	Takemi Kamata NEC Corp. 5-33-1 Shiba Minato-ku, Tokyo
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2
Tetsuya Yasuda
NEC Corp.
5-33-1 Shiba Minato-ku,
Tokyo

Applicant:

NEC Corp.
5-33-1 Shiba Minato-ku,
Tokyo

Agent:

Tadashi Sugano,
patent attorney

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Claim

1. A workpiece holding mechanism for a plane polishing device characterized in that it contains a holding part, which holds a workpiece that is on top of the polishing surface of the plane polishing device and is equipped with a convex spherical surface centering around one point on the surface of the said workpiece to be processed; a support part, which is provided for maintaining a constant orientation and is equipped with a concave spherical surface, which engages with the aforementioned convex spherical surface in a freely oscillating manner centering about one point on the aforementioned workpiece; and a flexible body, which is provided between the aforementioned holding part and the aforementioned supporting part and has high torsional rigidity but can bend freely.

Detailed explanation of the invention

Industrial application field

The present invention concerns a workpiece holding mechanism for a plane polishing device. In particular, it concerns a holding mechanism for a workpiece in a plane polishing device which polishes the surface of thin plates.

Prior art

Generally, a workpiece holding mechanism for a plane polishing device is constructed to include a holding area, where the workpiece is held on top of a polishing surface of the plane polishing device, and the surface of the workpiece is polished by oscillating [vibrating while moving] the workpiece over the polishing surface.

Figure 2 is a longitudinal section of a workpiece holding mechanism for a plane polishing device of the prior art. In Figure 2, a disk (1) of the plane polishing device is rotated about a shaft (2). Also, a sleeve (4) is attached to a frame (3) of the plane polishing device in a freely rotatable manner, and a splined shaft (5) is attached to the central hole of this sleeve (4) in a freely movable manner in the direction of the shaft and in such a manner that it rotates together with the sleeve (4) about the shaft. A lever (7), which is attached to an air cylinder (6) provided for the frame (3), engages with the splined shaft (5) in a freely rotatable manner. Also, a gear (9), which is attached to a motor (8) provided for the frame (3), engages with a gear (10), which is provided at the sleeve (4).

A hemispherical body (11) engages with the curved area in the form of a spherical surface that is provided at the front end of the splined shaft (5) in a freely oscillating manner. A pressing plate (12) is fixed to the hemispherical body (11), and a frame (13) is provided at the pressing plate (12). A pin (14), which is provided at the frame (13), engages with a groove (15), which is provided at the front end of the splined shaft (5). A compression spring (16), which is provided between the splined shaft (5) and the frame (13), interacts to press the hemispherical body (11) onto the splined shaft (5) in order to prevent the hemispherical body (11) from falling when the splined shaft (5) ascends.

A through-hole (17), which is provided at the pressing plate (12), and a through-hole (18), which is provided between the hemispherical body (11) and the pressing plate (12), are connected to a vacuum pump (not shown) through a pipe (19), which passes through a hole provided at the splined shaft (31), in order to vacuum hold material (20), which is a magnetic disk forming the workpiece, onto the pressing plate (12). A ring (21) is also provided and fixed at the pressing plate (12) in order to determine the position of the material (20).

To polish the surface of the material (20) with this plane polishing device, the air cylinder (6) is actuated so that the pressing plate (12) ascends and so that the material (20) is vacuum held against the inner side of the ring (21) at the lower surface of the pressing plate (12). Next, the pressing plate (12) is lowered by the air cylinder (6) through rotation of the motor (8), and the material (20) is pressed against the polishing surface (22) of the disk (1). Also, a polishing solution (not shown) is spread over the polishing surface (22). Accordingly,

the bottom surface of the material (20) is polished by the action of its own rotations and vibrations by the rotation of the disk (1).

The polishing surface (22) of the disk (1) is processed to have a flat surface; however, a small amount of waviness remains in many actual cases. Accordingly, it is necessary for the material (20) and the pressing plate (12) to be able to tilt slightly along the waviness of the polishing surface (22) in order for the material (20) constantly to adhere close to the polishing surface (22) for a smooth finish. This tilting is obtained when the hemispherical body (11) vibrates with the spherical concave area of the splined shaft (5). Moreover, the material (20) tilts while centering around the center C because the center C of the spherical surface of the hemispherical body (11) is established to be positioned at the bottom surface of the material (20), and the position of the bottom surface of the material (20) does not change even though it is tilted, and polishing can occur.

The pipe (19) is elastic and can absorb some tilting in the hemispherical body (11). Also, the hemispherical body (11) vibrates around the splined shaft (5); therefore, it is designed so that the rotation by the motor (8) is transmitted to the pressing plate (12) and the material (20) when the pin (14) engages with the groove (15).

Problems to be solved by the invention

However, the ability of the pressing plate (12) and material (20) to follow the waviness of the polishing surface (22) was not satisfactory. One factor is the generation of a large amount of

friction between the pin (14) and the groove (15). Figure 3 is a schematic diagram explaining the force that is applied to the pin (14), and it corresponds to the right side surface diagram of the major part in Figure 2. In Figure 3, force b, which is equal to the friction between the material (20) and the polishing surface (22), is applied to the groove (15) from the pin (14) when the splined shaft (5) rotates, as illustrated by arrow a.

Furthermore, since a condition is created, in which the right side opens between the material (20) and the polishing surface (22), as illustrated in Figure 1, by the waviness of the polishing surface (22), and if force P is obtained by the piston (6), force P interacts upwards at the left edge of the material (20). To consider the equilibrium of the moment about center C, where the length between center C of the spherical surface of the hemispherical body (11) and the left edge of the material (20) is d and the height between center C and the pin (14) is h, a force of Pd/h is also applied to the pin (14). In practice, this force P becomes considerably large; therefore, a large force also acts on the pin (14), resulting in a large frictional force.

There was also the problem of the pin (14) being constantly pressed toward the left by the groove (15) in Figure 3, causing the pressing plate (12) to swing around the pin (14) according to the waviness of the polishing surface (22), the base ([illegible]) of the pin (14) to change its position to the left or the right relative to the splined shaft (5), and a fluctuation to occur in the rotation of the pressing plate (12).

The aim of the present invention is to offer a workpiece holding mechanism for a plane polishing device in which the aforementioned problems are solved, there is a satisfactory following of the waviness of the polishing surface by tilting of

the workpiece, and the fluctuation in the rotation of the workpiece is reduced for a smooth polishing of the workpiece.

Means to solve the problems

The present invention comprises a holding part (34), which holds the workpiece that is on top of the polishing surface of the plane polishing device and is equipped with a convex spherical surface centering around one point on the surface of the said workpiece to be processed; a support part (32), which is provided for maintaining a constant orientation and is equipped with a concave spherical surface, which engages with the aforementioned convex spherical face in a freely vibrating manner centering about one point on the aforementioned workpiece; and a flexible body (36), which is provided between the aforementioned holding part (34) and the aforementioned support part (32) and has high torsion rigidity but can bend freely.

Function

The elastic body (36), which has torsional rigidity but can bend freely, tilts the holding part (34) against the support part (32) while following the waviness of the polishing surface and not generating a large amount of friction. During this process, the holding part (34) does not separate from the support part (32) in the direction of rotation.

Application example

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Next, an application example of the present invention will be explained with reference to a figure. Figure 3 [sic; 1] is a longitudinal section of an application example of the present invention. A disk (1), shaft (2), frame (3), sleeve (4), air cylinder (6), lever (7), motor (8), and gears (9) and (10) are the same as those illustrated in Figure 1 [sic; 2]. A splined shaft (31) is attached to the sleeve (4) so that it can freely oscillate in the direction of the shaft and rotate together with it around the shaft. A hemispherical body (33) engages with the concave part in the form of a spherical surface, which is provided at a flange (32) at the lower end of the splined shaft (31) in a freely oscillating manner. A pressing plate (34) is fixed to the hemispherical body (33). A through-hole (35) of the pressing plate (34) is connected to a pipe (19) in order to hold the material (20) against the pressing plate (34).

The upper end of bellows (36) is fixed to the flange (32) and its lower end to the pressing plate (34). The torsional rigidity of the bellows (36) with respect to the central shaft is high, but it can expand and bend in the direction of the central shaft; therefore, the pressing plate (34) does not separate from the flange (32) in the direction of rotation, but it can tilt freely. Accordingly, a large frictional force is not generated even when the pressing plate (34) is tilted, and the pressing plate (12) and the material (20) satisfactorily follow the waviness of the polishing surface.

The present invention can also be applied to plane polishing devices, in which the disk is fixed, and the pressing plate (34),

3

for example, rotates together with the frame (3) around the shaft (12).

A steel ball, for example, may also be included between the concave spherical surface of the supporting part and the convex spherical surface of the holding part so that the friction can be reduced.

Furthermore, the elastic body that is provided between the support part and the holding part does not necessarily have the form of a bellows. For example, dividing the bellows in the circumferential direction, in other words, several plate springs that are bent in the middle and arranged over the circumference may also be used.

Effect of the invention

As explained above, in the workpiece holding mechanism for a plane polishing device of the present invention, the holding part is tilted without the generation of a large amount of friction between the groove and the pin by using an elastic body which has torsional rigidity but which can expand and bend freely, instead of an engagement between the groove and the pin, and the workpiece can satisfactorily tilt with and follow the waviness of the polishing surface.

Also, oscillations around the pin are eliminated when the support part is tilted, a fluctuation in the rotating speed of the workpiece can be made very small, and the effect is smooth polishing of the workpiece.

Brief description of the figures

Figure 1 is a longitudinal section of an application example of the present invention. Figure 2 is a longitudinal section of an example of a workpiece holding mechanism for a plane polishing device of the prior art. Figure 3 is a model diagram which explains the force which interacts on the pin (14) as an example illustrated in Figure 2.

1...disk, 5, 31...splined shaft, 11, 33...hemispherical body, 12, 34...pressing plate, 14...pin, 15...groove, 20...material, and 36...bellows.

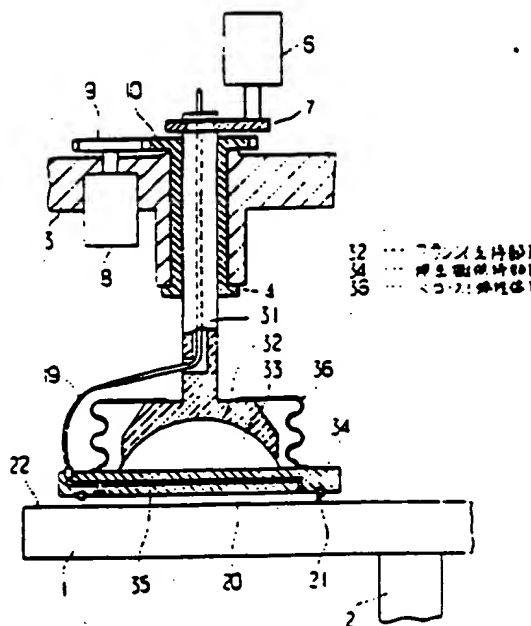


Figure 1

Key: 32 Flange (supporting part)
 34 Pressing plate (holding part)
 36 Bellows (elastic body)

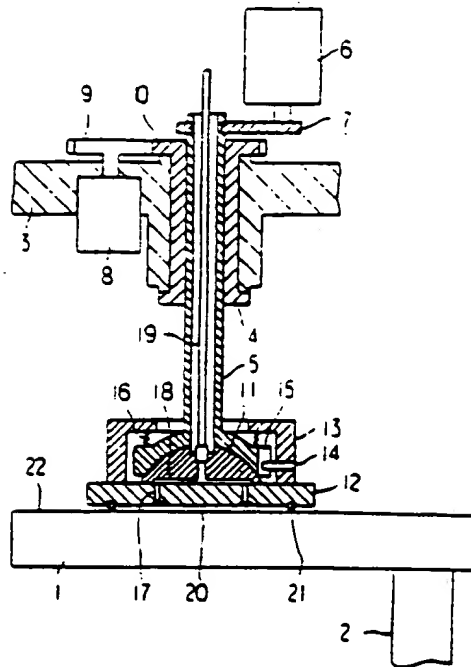


Figure 2

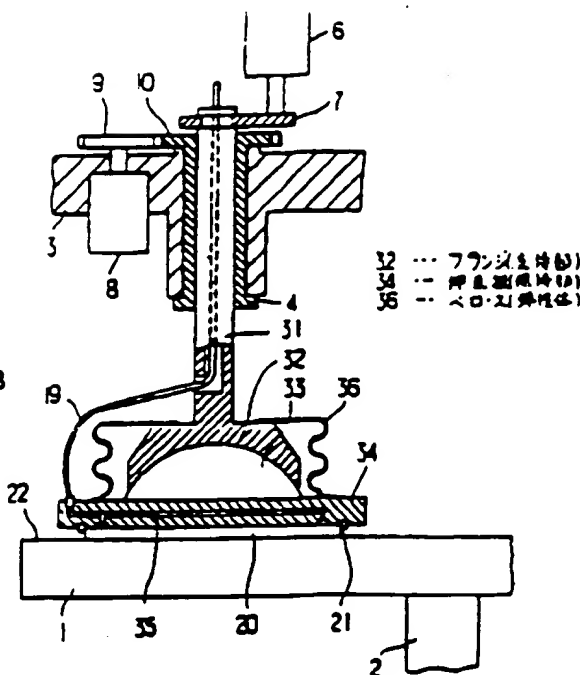
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 PATENT DATE: 04-02-1986

INVENTOR : KAMATA TAKEMI; others: 01

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 B24B41/06

TITLE : WORK HOLDING MECHANISM FOR
 SURFACE POLISHING MACHINE



ABSTRACT : PURPOSE: To polish a work smoothly by providing a resilient bellows between the work holding section having convex face and the supporting member having concave face engagable slidably with the convex face.
 CONSTITUTION: Semi-spherical body 33 secured to a pressboard 34 is engaged slidably with spherical recess made in the lower end flange 32 of spline shaft 31 to adsorb a material 20 through a hole 35 communicated with a tube 19 to the pressboard 34. A bellows 36 having high rigidity in the rotary direction while flexible against the vertical shrinkage and bending is secured between said flange 32 and the pressboard 34. Consequently, the work 20 or the pressboard 34 will follow the waving of the polishing face 22 well to reduce the fluctuation of the rotary speed of the work 20 thus to polish the work 20 smoothly.

三井物産株式会社

9461 - 25768

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⑦角 明 著 安 田 哲 也 東京都港区芝5丁目33番1号 日本電気株式会社内

の出 人 日本電気株式会社 東京都港区芝5丁目33番1号

代理人 弁理士 菅野 中

• • •

1. 愚明の名称

平遥县融媒体中心·城工物信网

1. 零售店及公租屋

(1) 半圓形断面の鋼管上の管加工物を保持し、この管加工物の管加工面上の一点を中心とする三角形を有する保持部と、保持部を一定に保つて置けられ、前記管加工物上の一点を中心とし、前記三角形の頂角位置に重合する凹部を有する支持部と、前記保持部と前記支持部の間に置けられ、張り付いては前記凹部が大きく曲げられてはる軟な弾性体とを有することを特徴とする半圓形断面の管加工物保持装置。

1 異質の浮遊と沈降

： 1 2 3 4 5 6 7 8 9 10 11 12 13 14 15 16 17 18 19 20 21 22 23 24 25 26 27 28 29 30 31 32 33 34 35 36 37 38 39 40 41 42 43 44 45 46 47 48 49 50 51 52 53 54 55 56 57 58 59 60 61 62 63 64 65 66 67 68 69 70 71 72 73 74 75 76 77 78 79 80 81 82 83 84 85 86 87 88 89 90 91 92 93 94 95 96 97 98 99 100 101 102 103 104 105 106 107 108 109 110 111 112 113 114 115 116 117 118 119 120 121 122 123 124 125 126 127 128 129 130 131 132 133 134 135 136 137 138 139 140 141 142 143 144 145 146 147 148 149 150 151 152 153 154 155 156 157 158 159 160 161 162 163 164 165 166 167 168 169 170 171 172 173 174 175 176 177 178 179 180 181 182 183 184 185 186 187 188 189 190 191 192 193 194 195 196 197 198 199 200 201 202 203 204 205 206 207 208 209 210 211 212 213 214 215 216 217 218 219 220 221 222 223 224 225 226 227 228 229 230 231 232 233 234 235 236 237 238 239 240 241 242 243 244 245 246 247 248 249 250 251 252 253 254 255 256 257 258 259 260 261 262 263 264 265 266 267 268 269 270 271 272 273 274 275 276 277 278 279 280 281 282 283 284 285 286 287 288 289 290 291 292 293 294 295 296 297 298 299 300 301 302 303 304 305 306 307 308 309 310 311 312 313 314 315 316 317 318 319 320 321 322 323 324 325 326 327 328 329 330 331 332 333 334 335 336 337 338 339 340 341 342 343 344 345 346 347 348 349 350 351 352 353 354 355 356 357 358 359 360 361 362 363 364 365 366 367 368 369 370 371 372 373 374 375 376 377 378 379 380 381 382 383 384 385 386 387 388 389 390 391 392 393 394 395 396 397 398 399 400 401 402 403 404 405 406 407 408 409 410 411 412 413 414 415 416 417 418 419 420 421 422 423 424 425 426 427 428 429 430 431 432 433 434 435 436 437 438 439 440 441 442 443 444 445 446 447 448 449 450 451 452 453 454 455 456 457 458 459 460 461 462 463 464 465 466 467 468 469 470 471 472 473 474 475 476 477 478 479 480 481 482 483 484 485 486 487 488 489 490 491 492 493 494 495 496 497 498 499 500 501 502 503 504 505 506 507 508 509 510 511 512 513 514 515 516 517 518 519 520 521 522 523 524 525 526 527 528 529 530 531 532 533 534 535 536 537 538 539 540 541 542 543 544 545 546 547 548 549 550 551 552 553 554 555 556 557 558 559 560 561 562 563 564 565 566 567 568 569 570 571 572 573 574 575 576 577 578 579 580 581 582 583 584 585 586 587 588 589 590 591 592 593 594 595 596 597 598 599 600 601 602 603 604 605 606 607 608 609 610 611 612 613 614 615 616 617 618 619 620 621 622 623 624 625 626 627 628 629 630 631 632 633 634 635 636 637 638 639 640 641 642 643 644 645 646 647 648 649 650 651 652 653 654 655 656 657 658 659 660 661 662 663 664 665 666 667 668 669 670 671 672 673 674 675 676 677 678 679 680 681 682 683 684 685 686 687 688 689 690 691 692 693 694 695 696 697 698 699 700 701 702 703 704 705 706 707 708 709 710 711 712 713 714 715 716 717 718 719 720 721 722 723 724 725 726 727 728 729 730 731 732 733 734 735 736 737 738 739 740 741 742 743 744 745 746 747 748 749 750 751 752 753 754 755 756 757 758 759 760 761 762 763 764 765 766 767 768 769 770 771 772 773 774 775 776 777 778 779 780 781 782 783 784 785 786 787 788 789 790 791 792 793 794 795 796 797 798 799 800 801 802 803 804 805 806 807 808 809 810 811 812 813 814 815 816 817 818 819 820 821 822 823 824 825 826 827 828 829 830 831 832 833 834 835 836 837 838 839 840 841 842 843 844 845 846 847 848 849 850 851 852 853 854 855 856 857 858 859 860 861 862 863 864 865 866 867 868 869 870 871 872 873 874 875 876 877 878 879 880 881 882 883 884 885 886 887 888 889 890 891 892 893 894 895 896 897 898 899 900 901 902 903 904 905 906 907 908 909 910 911 912 913 914 915 916 917 918 919 920 921 922 923 924 925 926 927 928 929 930 931 932 933 934 935 936 937 938 939 940 941 942 943 944 945 946 947 948 949 950 951 952 953 954 955 956 957 958 959 960 961 962 963 964 965 966 967 968 969 970 971 972 973 974 975 976 977 978 979 980 981 982 983 984 985 986 987 988 989 990 991 992 993 994 995 996 997 998 999 1000 1001 1002 1003 1004 1005 1006 1007 1008 1009 1010 1011 1012 1013 1014 1015 1016 1017 1018 1019 1020 1021 1022 1023 1024 1025 1026 1027 1028 1029 1030 1031 1032 1033 1034 1035 1036 1037 1038 1039 1040

本館では、上述研究施設の加工工施設設備等、
他の施設の英訳を研究するための予選研究施設の
加工工施設設備設備する。

(或 變 遷 的)

一般に各種の電機設備の施工工事は、平

酒類の製造に關する研究は、酒類工業を促進する目的
を以て行われ、酒類工業の発展に資するものとして、
酒類工業の振興を期してゐる。

第2図は、従来の平面伊勢屋型の複合二階貸付受取の展開図型である。第2図から見て平面伊勢屋型の内装は廊下を中心として回転を要される。一方平面伊勢屋型のフロームにはエレベーターが回転自在に取り付けられ、このエレベーターを中心にスライディング廊下が随分方向に回転するフロームと一体となって回転するように取り付けられている。エレベーターが回転できるようにエレベーターを取り付けたいところではエレベーターが回転自在でなければならない。またエレベーターに付いたフロームを取り付けたいところではエレベーターが回転自在でなければならない。

[illegible]

同じ回転方向にすればよい。

(実施例)

次に本発明の実施例について図面を参照して説明する。第1図は本発明の一実施例の断面図である。円筒1、軸2、フレーム3、スリーブ4、エアシリンダ5、レバー7、ギヤ8、歯車9、10は第1図に示すものと同じである。スプライン軸11は、軸方向に移動自在に軸筒の内部に一体となつて回転するようにスリーブ4に取り付けられている。スプライン軸11の下端のフランジ12に設けた歯状の凹部13に半球体14が回転自在に係合している。半球体14に押圧部16が固着されている。押圧部16の通孔15は管19と通連され、管20を押圧部16に接するたののものである。

ベローズ18が上端をフランジ12に覆着し下端を押圧部16に固着して設けられている。ベローズ18は軸の周囲の回りくわじりに対して剛性が大きいので、軸方向の伸縮及び曲げに対しては柔軟であるため、押圧部16はフランジ12に対し軸方向にずれやすいが、しかも自由に動くことが

できる。従つて押圧部16が傾くときも大きな摩擦力を生じず押圧部12及び管20の研削面がわりわたりする適成性はよい。

また本発明は、円筒が固定してある場合にも同様に押圧部16が軸2を中心として回転するように平面研削装置にも適用できる。

また支持部と保持部との凸凹面の間に潤滑油等を介在させて、摩擦力を減少させることもできる。

さらに支持部と保持部との間に設ける弾性体は、必ずしもベローズの形状をしている必要はない。例えばベローズを周方向に分割したもの、言い換えれば中間を彎曲させた管状の板ばねを円周上に並べたものでもよい。

(発明の効果)

本発明の平面研削装置の被加工物保持機構は、以上説明したように歯とピンとの係合の代わりになり、軸には剛性を有し伸縮及び曲げに対して柔軟性のある弾性体を用いることにより、歯とピンとの間の力を摩擦力を発生させることなく保持部

が傾き、研削面のうねりに対する被加工物の傾きの適成性をよくすることができ、

また保持部が傾くときにピンを中心として回転することができ、被加工物の回転速度の変動を非常に小さくすることができ、円筒に被加工物を研削できる効果がある。

6. 図面の簡単な説明

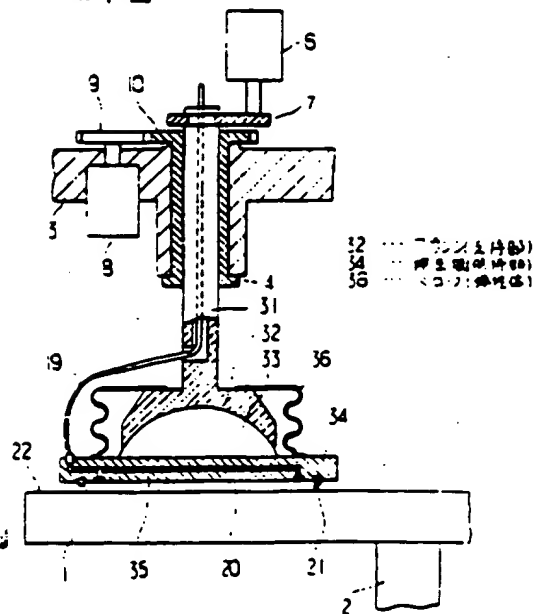
第1図は本発明の一実施例の断面図、第2図は平面研削装置の被加工物保持機構の従来の一例の断面図、第3図は第2図に示す一例のピン16に作用する力を説明するための模式図である。

1 円筒、5、31 スプライン軸、11、33 半球体、12、36 押圧部、14 ピン、15 管、20 管、30 ベローズ。

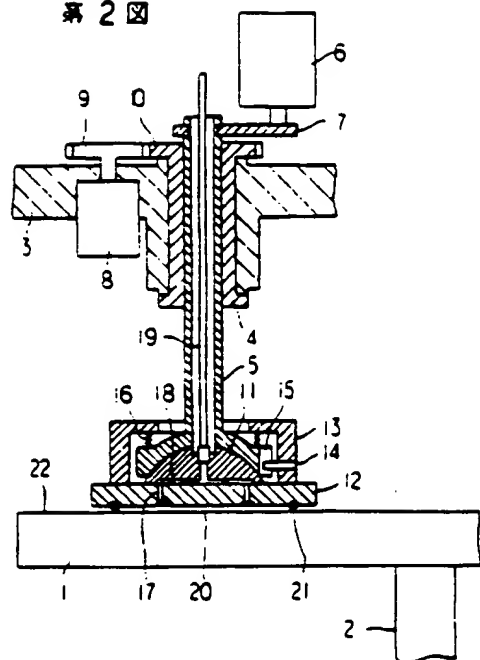
特許出願人 日本電機株式会社

代理人 渡辺 孝 野 中

第1図



第 2 图



第 3 图

